

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

**Applicant(s):** William G. America, et al.

**Examiner:** Jack S. J. Chen

**Serial No:** 10/674,646

**Art Unit:** 2813

**Filed:** September 30, 2003

**Docket:** YOR920030320US1 (16868)

**For:** PLASMA SURFACE MODIFICATION  
AND PASSIVATION OF ORGANO-  
SILICATE GLASS FILMS FOR  
IMPROVED HARDMASK ADHESION  
AND OPTIMAL RIE PROCESSING

**Dated:** June 29, 2007

**Confirmation No.** 4797

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Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

**RESPONSE UNDER 37 C.F.R. § 1.116**

Sir:

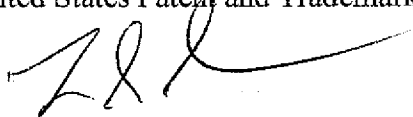
In response to the Final Office Action dated April 4, 2007, and in accordance with the provisions of 37 C.F.R. §1.116, Applicants submit the following remarks for entry in the above-identified case.

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**CERTIFICATE OF ELECTRONIC FILING**

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Dated: June 29, 2007

  
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Leslie S. Szivos, Ph.D.